

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Victor Higgs
Assignee: Nanometrics Incorporated
Title: Detection Method and Apparatus Metal Particulates on Semiconductors
Serial No.: 10/549,865 Filing Date: July 28, 2006
Examiner: Isiaka O. Akanbi Group Art Unit: 2886
Docket No.: NAN165 US (8037) Confirmation No: 4772

Saratoga, California
February 13, 2008

MS Amendment
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicant submits for consideration in the above-identified patent application the documents listed on the accompanying Form PTO/SB/08B. Copies of these documents are submitted herewith. The Examiner is requested to make all of the listed documents of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicant would appreciate the Examiner initialing and returning the Form PTO/SB/08, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not

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exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Michael J. Halbert", written in a cursive style.

Michael J. Halbert
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